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Dated: February 28, 2005

Signature: Marla L. Hudson
(Marla L. Hudson)

Docket No.: 30203/38233
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Evren Eryurek et al.

Application No.: 10/085,445

Confirmation No.: 1836

Filed: February 28, 2002

Art Unit: 2121

For: FIDUCIAL TECHNIQUE FOR ESTIMATING
AND USING DEGRADATION LEVELS IN A
PROCESS PLANT

Examiner: Thomas K. Pham

AMENDMENT AFTER FINAL ACTION (37 C.F.R. § 1.116)

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated December 28, 2004, rejecting claims 1-27 and 29-35, applicants respectfully request reconsideration of the application in view of the following amendments and remarks.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.

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